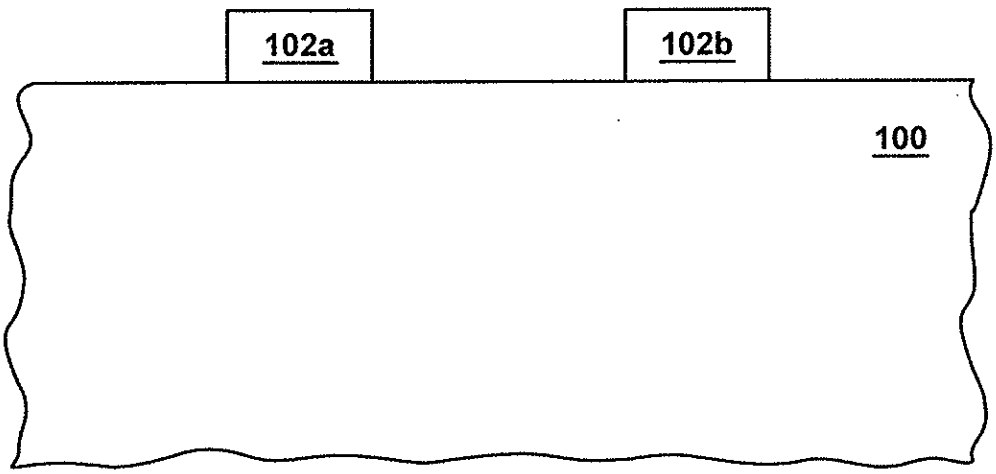



FIG. 1A

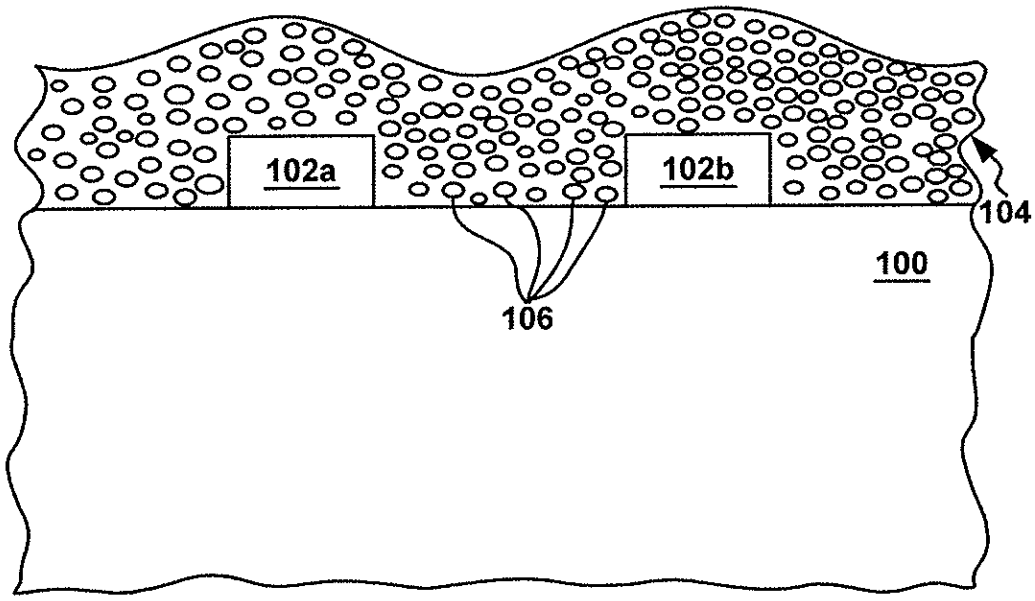



FIG. 1B

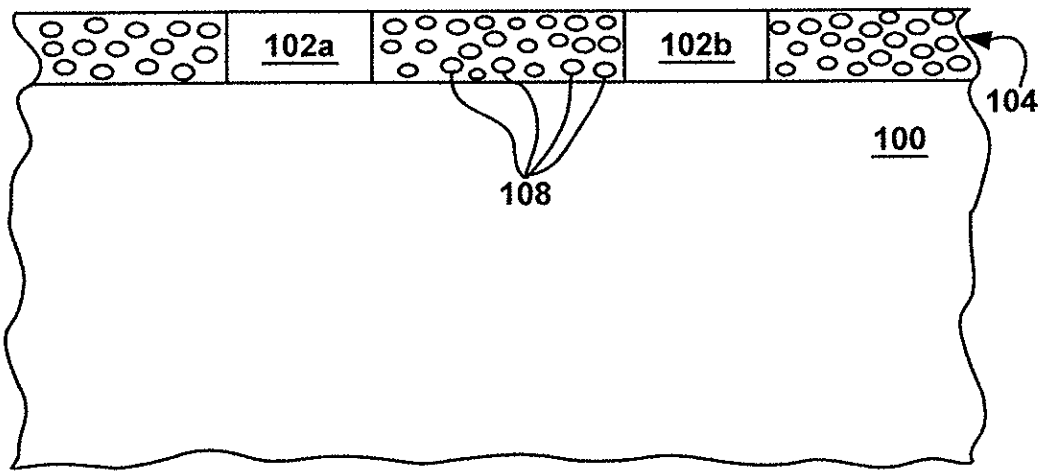



FIG. 1C

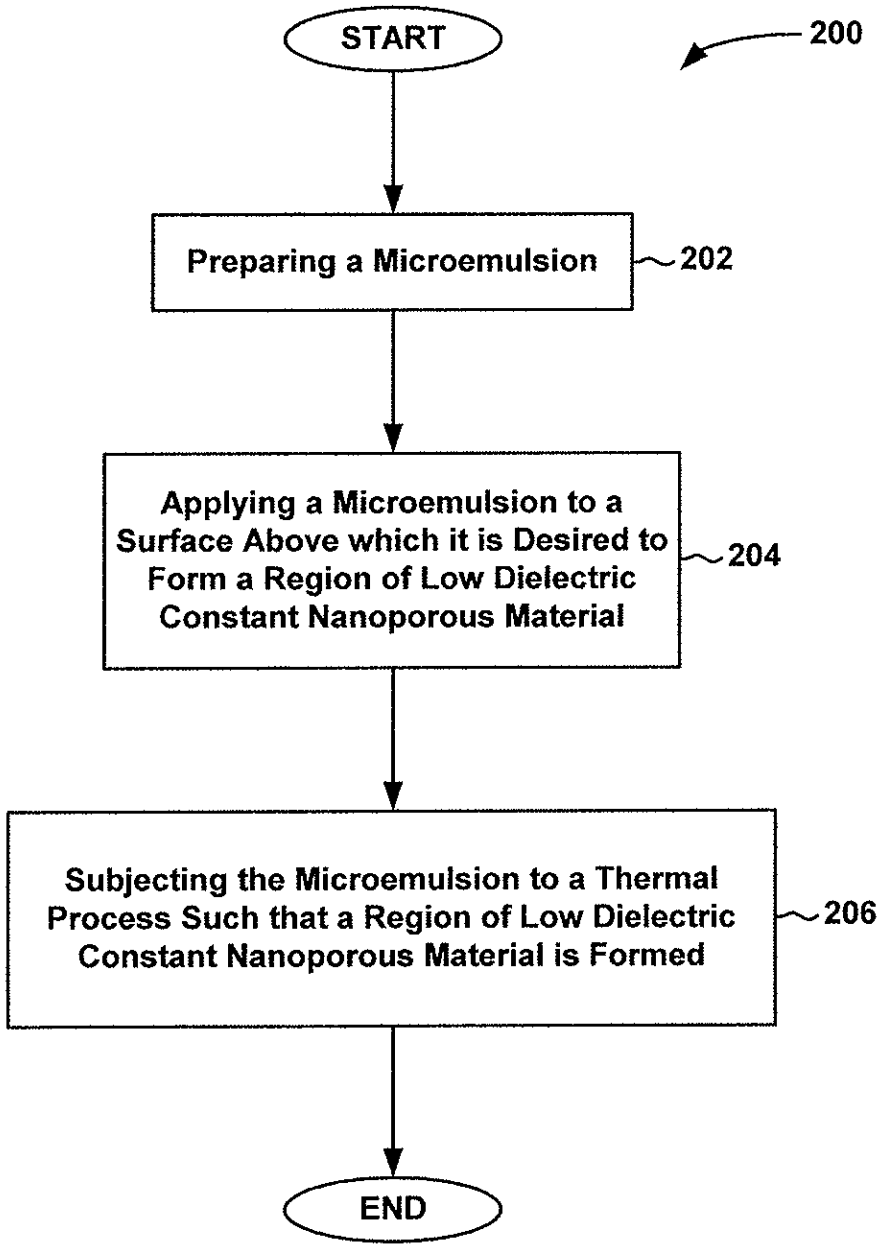

START
200
Preparing a Microemulsion
202
Applying a Microemulsion to a Surface Above which it is Desired to Form a Region of Low Dielectric Constant Nanoporous Material
204
Subjecting the Microemulsion to a Thermal Process Such that a Region of Low Dielectric Constant Nanoporous Material is Formed
206
END

FIG. 2

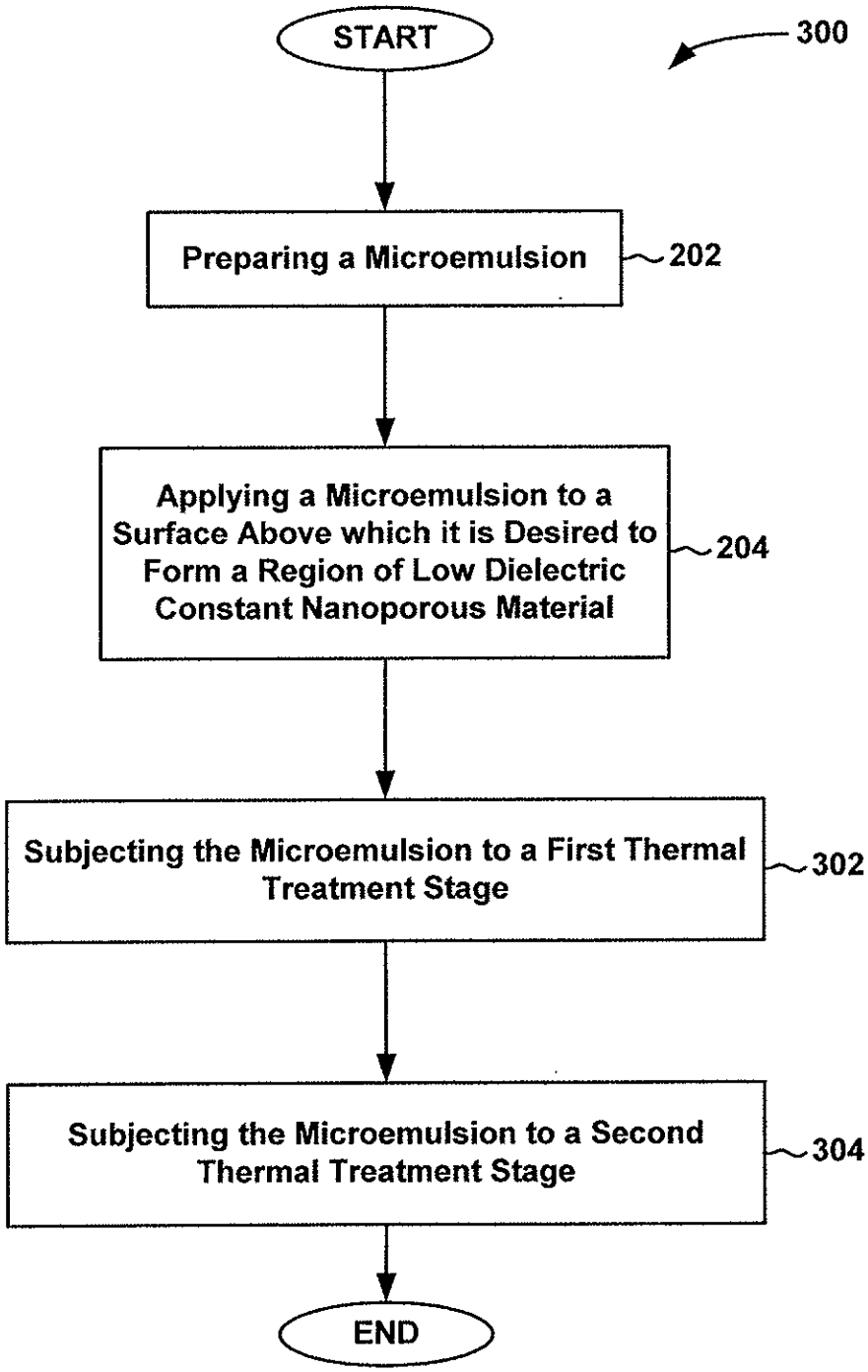

START
300
Preparing a Microemulsion
202
Applying a Microemulsion to a Surface Above which it is Desired to Form a Region of Low Dielectric Constant Nanoporous Material
204
Subjecting the Microemulsion to a First Thermal Treatment Stage
302
Subjecting the Microemulsion to a Second Thermal Treatment Stage
304
END

FIG. 3